

IN THE SPECIFICATION:

Please amend the two paragraphs beginning at line 6, page 1 of the specification, as follows.

This application is a continuation-in-part of a pending patent application entitled, METHODS FOR FABRICATING OXIDE THIN FILMS, invented by Joshi et al., Serial No. 10/801,374 [[____]], filed March 15, 2004 [[____]], Attorney Docket No. SLA787.

This application is a continuation-in-part of a pending patent application entitled, DEPOSITION OXIDE WITH IMPROVED OXYGEN BONDING, invented by Pooran Joshi, Serial No. 10/801,377 [[____]], filed March 15, 2004 [[____]], Attorney Docket No. SLA766.